

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Sun et al.	Examiner:	Thanh V. Pham
Serial No.:	10/621,292	Group Art Unit:	2823
Filed:	July 17, 2003		
For:	METHOD OF FABRICATING SEMICONDUCTOR DEVICE USING A NICKEL SALICIDE PROCESS		

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated November 28, 2006, please amend the above-referenced patent application as set forth herein.
